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Applicant: Robert E. Higashi et al.

LIST OF PATENTS AND PUBLICATION APPLICANT'S INFORMATION DISCLOSURE STATEMENT

Filing Date:	Group Art:
December 29, 2003	unknown

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Date	Name
100	5,895,233	04/1999	Higashi et al.
	6,036,872	03/2000	Wood et al.
17	6,359,333	03/2002	Wood et al.
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OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)

Motamedi et al., "Antireflection Surfaces in Silicon Using Binary Optics Technology," Applied Optics, Vol. 31, No. 2, pp. 4371-4376, August 1, 1002.			
DATE CONSIDERED: 12/02/2005			

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.